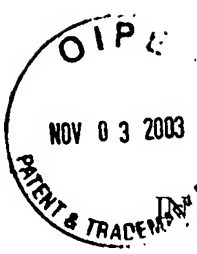


2877



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
JAMES BROC STIRTON
KEVIN R. LENSING
HORMUZDIAR E. NARIMAN
STEVEN P. REEVES

Examiner: Roy M. Punnoose
Group Art Unit: 2877
Att'y Docket: 2000.092400/TT5002
Customer No.: 23720

Serial No.: 10/084,987

Filed: February 28, 2002

For: METHOD OF USING HIGH YIELD
SPECTRA SCATTEROMETRY
MEASUREMENTS TO CONTROL
SEMICONDUCTOR MANUFACTURING
PROCESSES, AND SYSTEMS FOR
ACCOMPLISHING SAME

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RESPONSE TO OFFICE ACTION DATED SEPTEMBER 5, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
October 29, 2003 Date	<i>Mary Paul</i> Signature

This paper is submitted in response to the Office Action dated September 5, 2003, for which the three-month date for response is December 5, 2003.

No fee is believed to be due in connection with the present paper. However, the Director is authorized to deduct any fees required under 37 C.F.R. §§ 1.16 to 1.21, from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT5002. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.092400.